

**Stamp replication device and method for producing a holding means for
a stamp replication device as well as a stamp**

Abstract

5 A stamp replication device (10) for producing stamps for the production of
microstructured and/or nanostructured components comprising a platform (14), a
cover (12) that is positionable on the platform (14) and a holding means (32) for a
stamp carrier (28) , wherein the holding means (32) is provided on the cover (12)
or on the platform (14) and comprises a carrier (33) as well as a microstructured
10 vacuum surface (34) on the carrier (33) for holding the stamp carrier (28). In
addition, a method for producing a holding means (32) for a stamp replication
device (10) as well as a method for producing a stamp are specified.

Fig. 1